## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## PATENT APPLICATION

Applicant: Bera, et al.

Case: 8549/ETCH/DRIE/JB1

Serial No.: 10/821,310

Filed: **April 8, 2004** 

Examiner: **Zervigon, Rudy** 

Group Art Unit: 1763

Confirmation No.: 9721

TITLE:

APPARATUS FOR CONTROLLING GAS FLOW IN A

SEMICONDUCTOR SUBSTRATE PROCESSING CHAMBER

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SIR:

## RESPONSE TO OFFICE ACTION DATED JUNE 5, 2006

In response to the Office Action dated June 5, 2006, having a shortened statutory period for response set to expire on September 5, 2006, please enter this response and reconsider the claims pending in the application for the reasons discussed below. Applicants believe no fees are due in connection with this response. However, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782 for any fees, including extension of time fees or additional excess claim fees, required to make this response timely and acceptable to the Office.